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	Filing Date		2006-07-26		
	First Named Inventor Ho St		Sung CHO		
	Art Unit		1647		
	Examiner Name	Shula	mith H. SHAFER		
	Attorney Docket Numb	er	AMBX-0028.00US		

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	2	809 996	EP		A2	1997-12-03	F. HOFFMANN-LA ROCHE AG				
	3	921 131	EP		A1	1999-06-09	KYOWA HAKKO K CO., LTD.	OGYO			

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	4	946 736	EP	B1	1999-10-06	CHIRON CORPORATION				
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